

Second edition
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Lasers and laser-related equipment — Test methods for laser beam widths, divergence angles and beam propagation ratios —

Part 1: Stigmatic and simple astigmatic beams

*Lasers et équipements associés aux lasers — Méthodes d'essai des
largeurs du faisceau, angles de divergence et facteurs de limite de
diffraction —*

Partie 1: Faisceaux stigmatiques et astigmatiques simples



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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see www.iso.org/directives).

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For an explanation of the voluntary nature of standards, the meaning of ISO specific terms and expressions related to conformity assessment, as well as information about ISO's adherence to the World Trade Organization (WTO) principles in the Technical Barriers to Trade (TBT), see www.iso.org/iso/foreword.html.

This document was prepared by Technical Committee ISO/TC 172, *Optics and photonics*, Subcommittee SC 9, *Laser and electro-optical systems*, in collaboration with the European Committee for Standardization (CEN) Technical Committee CEN/TC 123, *Lasers and photonics*, in accordance with the Agreement on technical cooperation between ISO and CEN (Vienna Agreement).

This second edition cancels and replaces the first edition (ISO 11146-1:2005), which has been technically revised. The main changes compared to the previous edition are as follows:

- The terms and definitions were harmonized with the new edition of ISO 11145.
- The "principal axes" were defined more thoroughly and named as x' and y' . Quantities related to the principal axes coordinate system refer to this definition and use x' and y' in their indices.
- The requirements for the integration range for the determination of the second order moments have been relaxed.

A list of all parts in the ISO 11146 series can be found on the ISO website.

Any feedback or questions on this document should be directed to the user's national standards body. A complete listing of these bodies can be found at www.iso.org/members.html.

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Introduction

The propagation properties of every laser beam can be characterized within the method of second order moments by ten independent parameters (see ISO/TR 11146-3). However, due to their higher symmetry most laser beams of practical interest need fewer parameters for a complete description. Most lasers of practical use emit beams which are stigmatic or simple astigmatic because of their resonator design.

This document describes the measurement methods for stigmatic and simple astigmatic beams while ISO 11146-2 deals with the measurement procedures for general astigmatic beams. For beams of unknown type the methods of ISO 11146-2 are applicable. Beam characterization based on the method of second order moments as described in both parts is only valid within the paraxial approximation.

The theoretical description of beam characterization and propagation as well as the classification of laser beams is given in ISO/TR 11146-3, which is a Technical Report and describes the procedures for background subtraction and offset correction.

In this document, the second order moments of the power (energy) density distribution are used for the determination of beam widths. However, there may be problems experienced in the direct measurement of these quantities in the beams from some laser sources. In this case, other indirect methods of the measurement of the second order moments may be used as long as comparable results are achievable.

In ISO/TR 11146-3, three alternative methods for beam width measurement and their correlation with the method used in this document are described. These methods are:

- variable aperture method;
- moving knife-edge method;
- moving slit method.